

JP4

Atty. Dkt. No. 017700-0174

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Katsuya HASEGAWA et al  
Title: METHOD OF FORMING THIN FILM ON BASE  
SUBSTANCE VIA INTERMEDIATE LAYER  
Appl. No.: 10/526,745  
Filing Date: 03/07/2005  
Examiner: Unassigned  
Art Unit: 2812

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attn: Appl. Processing Division, Customer Correction Branch

Sir:

Attached is a copy of the official Filing Receipt received from the PTO in the  
above-referenced application.

There is an error with respect to the title. The title should read:

METHOD OF FORMING THIN FILM ON BASE SUBSTANCE VIA  
INTERMEDIATE LAYER.

There is also errors with respect to the Assignment For Published Patent Application.  
The Assignment For Published Patent Application should read:

SUMITOMO ELECTRIC INDUSTRIES, LTD., OSAKA, JAPAN  
INTERNATIONAL SUPERCONDUCTIVITY TECHNOLOGY CENTER, THE  
JURIDICAL FOUNDATION, TOKYO, JAPAN

The correction is not due to any error by Applicant and, accordingly, no fee is due. Issuance of a corrected Filing Receipt is respectfully requested.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 CFR §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

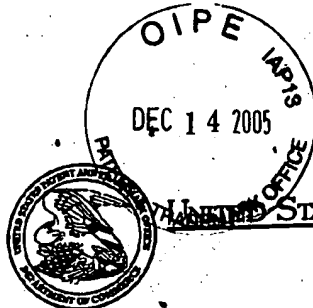
Respectfully submitted,

Date December 14, 2005

By Phillip J. Anticola *Reg. No. 38,819*

FOLEY & LARDNER LLP  
Customer Number: 22428  
Telephone: (202) 672-5407  
Facsimile: (202) 672-5399

*for /* David A. Blumenthal  
Attorney for Applicant  
Registration No. 26,257



## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/526,745	03/07/2005	2812	900	017700-0174	3	10	1

CONFIRMATION NO. 7863

FILING RECEIPT

\*OC000000016764943\*

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22428  
 FOLEY AND LARDNER  
 SUITE 500  
 3000 K STREET NW  
 WASHINGTON, DC 20007

Date Mailed: 08/15/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

Katsuya Hasegawa, Osaka-shi, JAPAN;  
 Teruo Izumi, Tokyo, JAPAN;  
 Yuh Shiohara, Tokyo, JAPAN;  
 Yoshihiro Sugawara, Nagoya-shi, JAPAN;  
 Tsukasa Hirayama, Nagoya-shi, JAPAN;  
 Fumiyasu Oba, Kyoto-shi, JAPAN;  
 Yuichi Ikuhara, Tokyo, JAPAN;

**Assignment For Published Patent Application**

Sumitomo Electric Industries, Ltd., Osaka, JAPAN  
 International Superconductivity Tec Ctr, The Judd, Tokyo, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 22428.

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/13887 10/29/2003

**Foreign Applications**

JAPAN 2002-318477 10/31/2002

**Projected Publication Date:** 11/17/2005

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Method for forming thin film on basic material through intermediate layer

**Preliminary Class**

438

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